HygroTwin[™] 2850 Trace Moisture, Relative Humidity, Pressure and Oxygen Analyzer

The HygroTwin[™] 2850 Analyzer System combines powerful features and maximum flexibility for accurate moisture analysis in a variety of process control applications. The instrument

incorporates two input channels for moisture, two input channels for temperature, and two additional inputs for trace oxygen, pressure, or other sensors.

The HygroTwin 2850 uses interchangeable probes to measure dew point temperatures in gases and non-conductive liquids from -110° C to $+20^{\circ}$ C (-166° F to $+68^{\circ}$ F) or 1 ppb_v to $+20^{\circ}$ C (68° F), relative humidity from 0-100% or dew point range from $<-15^{\circ}$ C to $+85^{\circ}$ C ($<5^{\circ}$ F to $+185^{\circ}$ F). The analyzer receives the moisture and temperature frequency signals from the probes and calculates the engineering units from a calibration table in the probes' memory. Thirty-one individual units of measure may be selected to indicate dew point, concentration, water vapor pressure, mixing ratio, absolute humidity, relative humidity, oxygen concentration and temperature. The HygroTwin can calculate change in moisture between two measurement points and express it in terms of absolute humidity or concentration units in lbs/MMSCF. This is useful in monitoring drying processes.

Features

- Accepts two humidity inputs
- Operates with trace moisture and relative humidity probes, ranging from -110°C to +85°C (-166°F to +185°F)
- Wide selection of engineering units with simple set-up and automatic reprogramming
- Analog and digital outputs to interface with external control devices
- In-line or bypass mounting, with one or two point continuous or multi-point spot checking capability

Dimensional Drawing &Ordering Information: See page 13

Analyzer Specifications

Electronics:	Continuous, self-checking, microprocessor controlled, updating measured value every 2 seconds	Eng. Units:	Indeper	dently assignable to display, outputs, and alarms.			
Accuracy:	±0.2%	Input Units:	Pressure bar. or	Pressure with correction (P in psig, inches of water column bar, or Torr): Oxygen (OX in ppm, or % by volume)		nches of water column, or % by volume)	
Instrument Range:	-130°C to +100°C (-202°F to +212°F) dew point, 1 ppb $_V$ to 10^6 ppb $_V,$ 0 to 45,000 lbs/MMSCF, 7x10-8 to 760 mmH g, 0 to 100%	Instrument Set-up:	By 3 pu constan	By 3 push-buttons and 4 programming levels: units, constants, and calibration data; outputs, alarms, and hard-			
Inputs:	2 each moisture, 2 each temperature, both accepting the probe frequency signals of 0 to 10,000 Hz typical, 2 each optional inputs, accepting 0 to 10,000 Hz, 1 to 5 VDC, or 4 to 20mA		calibration tables; special functions.				
		Display:	2 line, 80 character back lit LCD displays moisture, temperature, and additional inputs simultaneously				
Outputs:	4 each isolated, linear analog 4 to 20 mA into 500 ohms load, 0/1 to 5 V, load >10 kohms, user-assigned channel, unit, and span; 4 each alarm relays, SPDT, rating 250 VAC, 2.5A, user- assigned channel, unit, and set point; 1 each RS-232-C port, baud rate 110, 300, 1200, 2400, 4800, 9600, data bits 7 or 8, parity odd, even, or none; 2 each power supply for optional sensor 12/24 VDC, 50 mA	Operating & Storage Temp: 0° to 50°C (32°F to 122°F)					
		Power:	115 VAC, 50/60 Hz, 25 Watts°; 220 VAC, 12 VDC, 48 VDC, 24 VDC, optional; +15/-10 10% for 115 VAC				
		Battery Power: For Model 2850-6 12 VDC, 5 to 6 hour operation, built-in recharger (optional)					
Cable	301301 127 24 VDG, 30 IIIA	Weight:					
Connections:	NASA-approved push-in terminals	19" Rack Mount:		3.15 kg (7 lbs) Model 2850-3			
Program:	Non-volatile memory	Panel Mount:		2.7 kg (0 lbs) Model 2850-4 5.85 kg (1 3 lbs) Model 2850-5			
Data:	EEPROM	Portable/Bend	table/Bench Top:		5.4 kg (12 lbs), 14 lbs with battery Model 2850-6		
EMI/RFI/ESD		NEMA 3/4/7/9:		44.1 kg (98 lbs) Model 2850-7			
Resistance:	Exceeds IEC 801.2, ANSI C63; IEC 801.4, ANSI/IEEE C62.41; and IEC 801.5, ANSI/IEEE C62.41 standards	Enclosures: 19" Rack Mou	unt	Height 5.25"	Width 19"	Depth 11"	
Moisture Units: Dew Point (°C or °F); Relative Humidity (%); Concentration		Panel Mount		5.25"	10"	11"	
	(ppm _v , ppbv, vol %, mol %, lb/MMSCF; Concentration (liquid)	Panel Cutout		4.75"	8.625"		
	(ppm _W) - ppm _W ; Concentration (gas) - ppm _W ; Mixing Ratio	NEMA 4X		13.3"	11.3"	5.6"	
	(g/kg, lb/lb, gr/lb); Absolute Humidity (gr/ft ³ , g/m ³); Vapor Pressure (mmHg, mbar); Difference Process Temp. and Dew Point (change in °C, change in °F); Difference A&B in Mixing Ratio (g/kg, gr/lb); Difference A&B in Absolute Humidity (g/m ³ , gr/cf); Temperature Units (°C, °F)	Portable/Bend	ch Top	5.75"	11.5"	13.5"	
		NEMA 3/4/7	79, Cl. 1	,		5 1	
		Div. 1&2, Gr.	B, C, D	18"	18"	7"	
		Probes:	Relative Moistur	Humidity (Silie e Probes (Gole	con-based polym d/Aluminum O	ner capacitive) and Trace wide Capacitance) avail.	